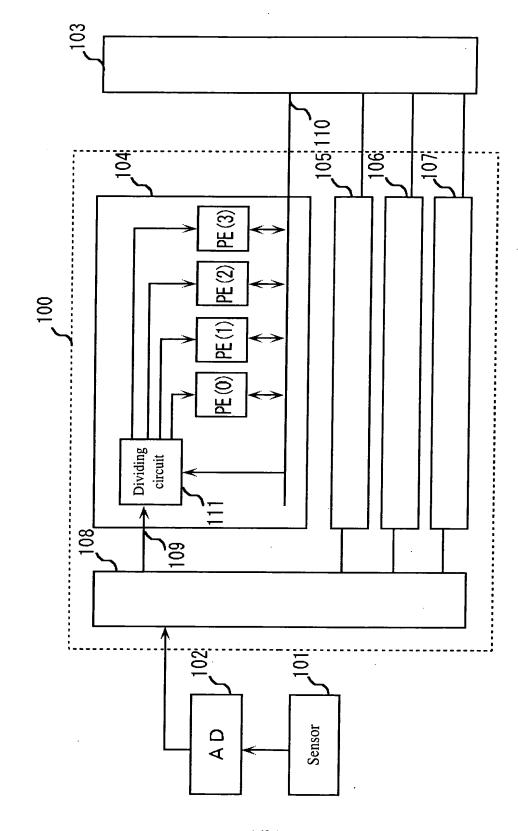
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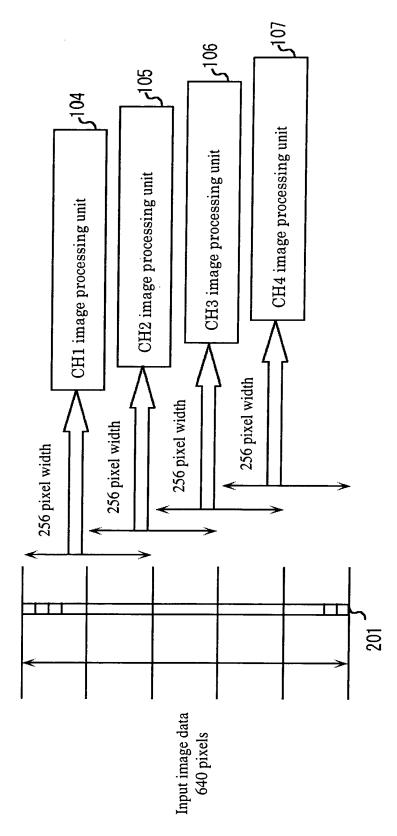
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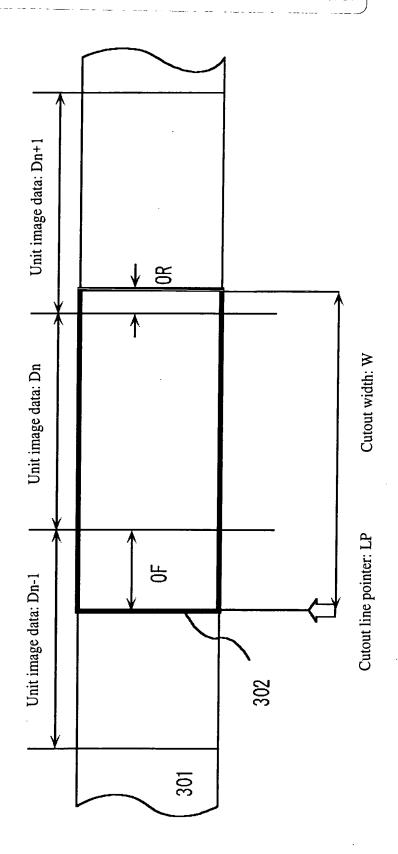
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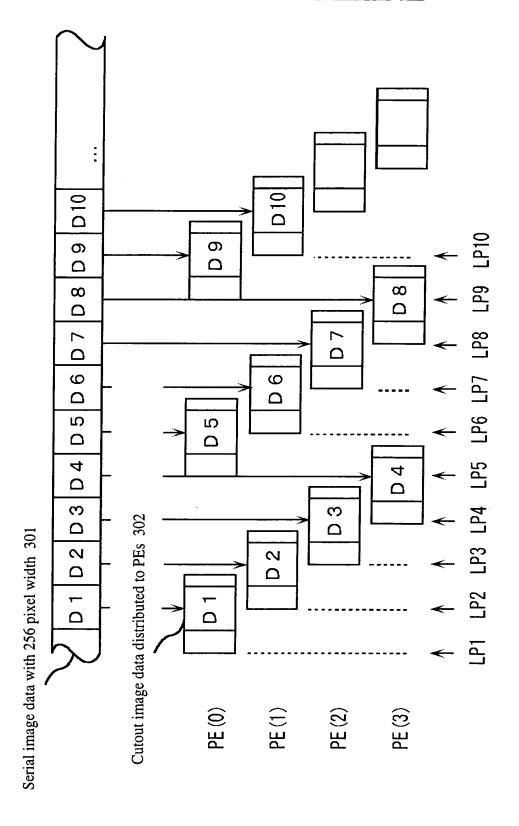


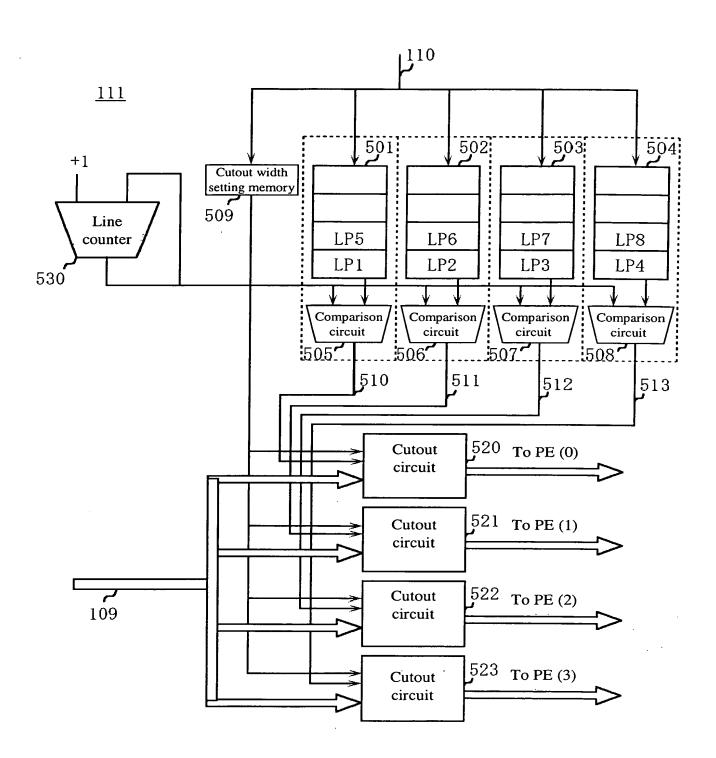
FIG. 4

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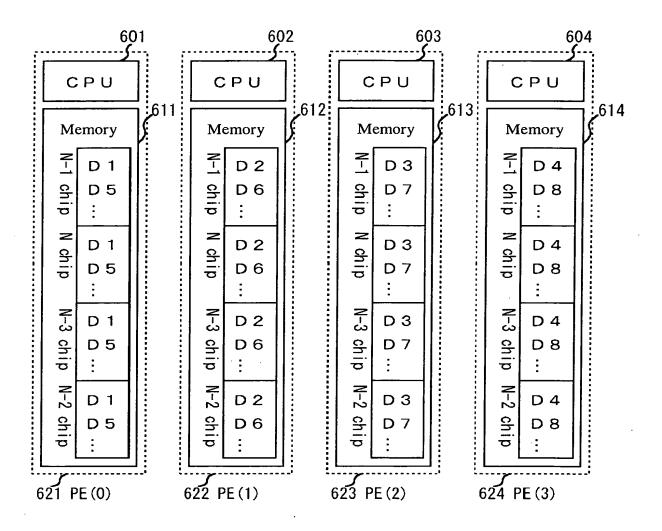
FIG. 5



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FIG. 6



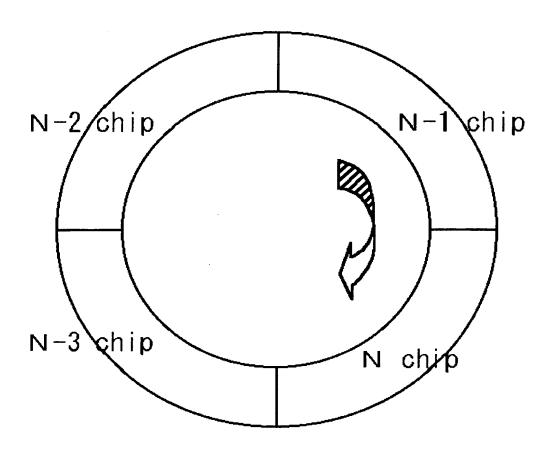
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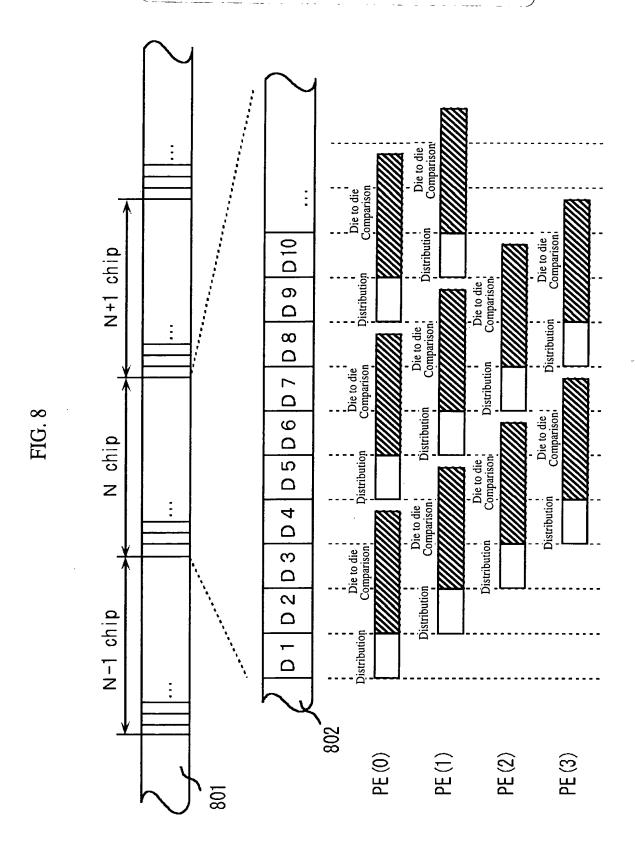
FIG. 7



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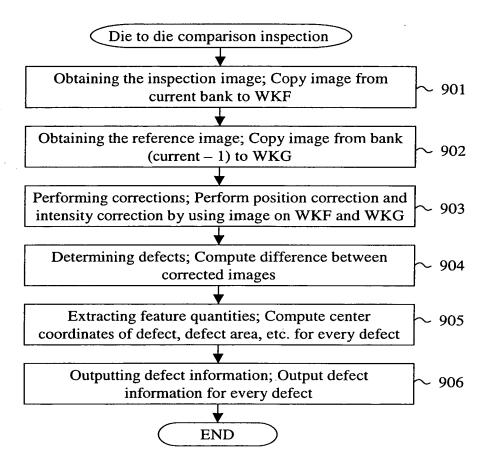


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FIG. 9



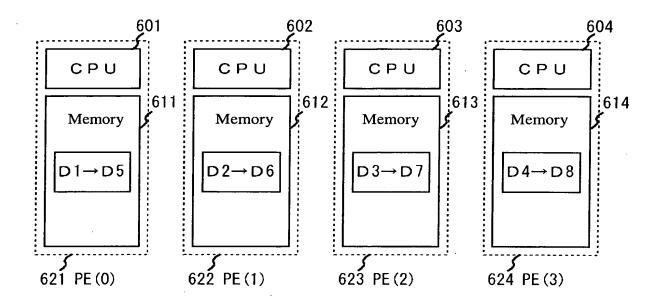
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FIG. 10



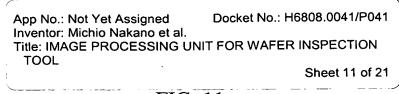
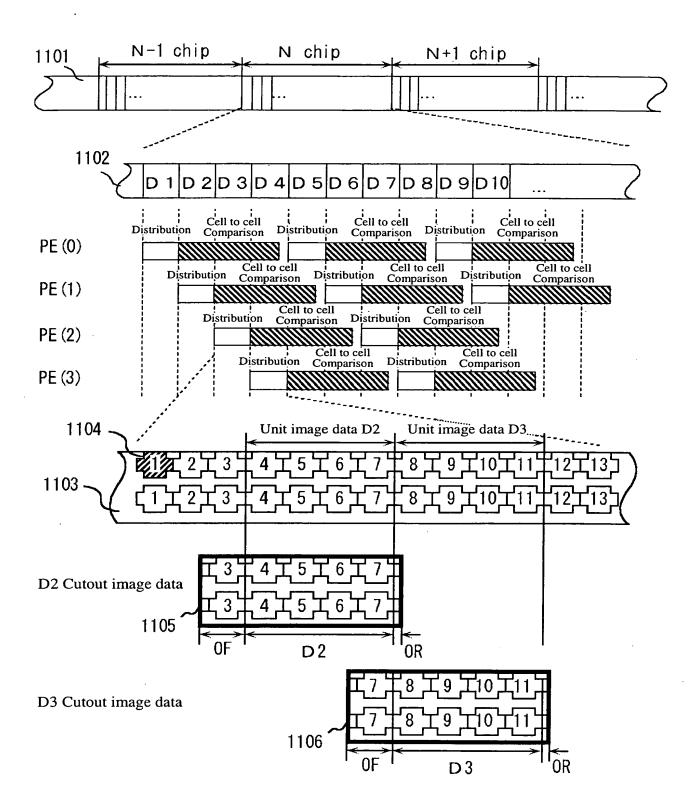
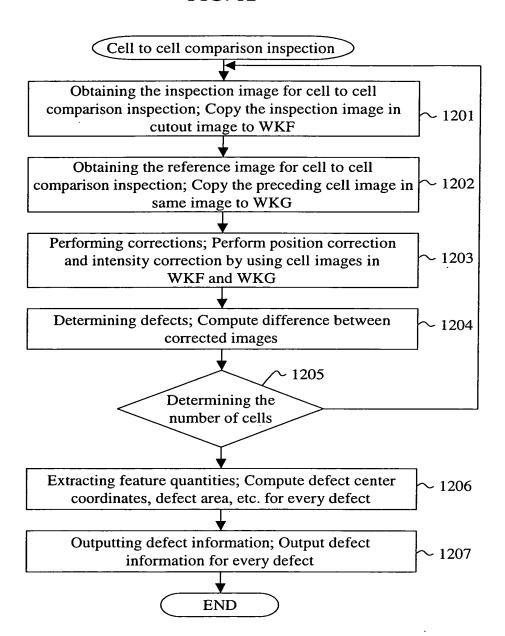


FIG. 11



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FIG. 12

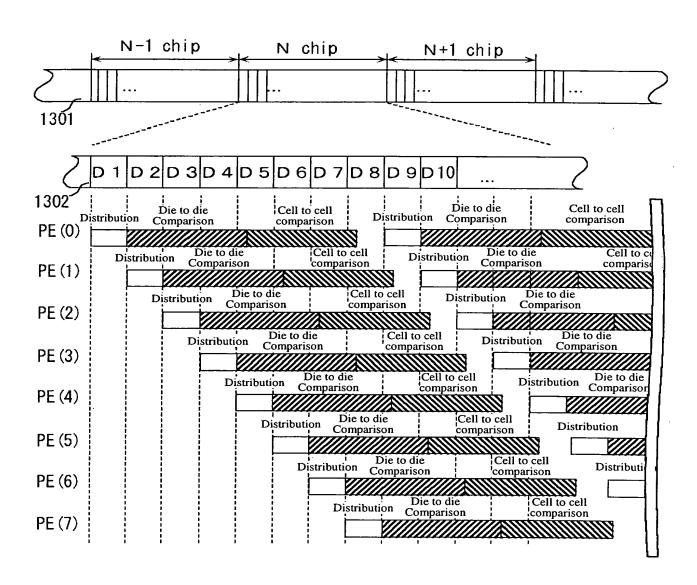


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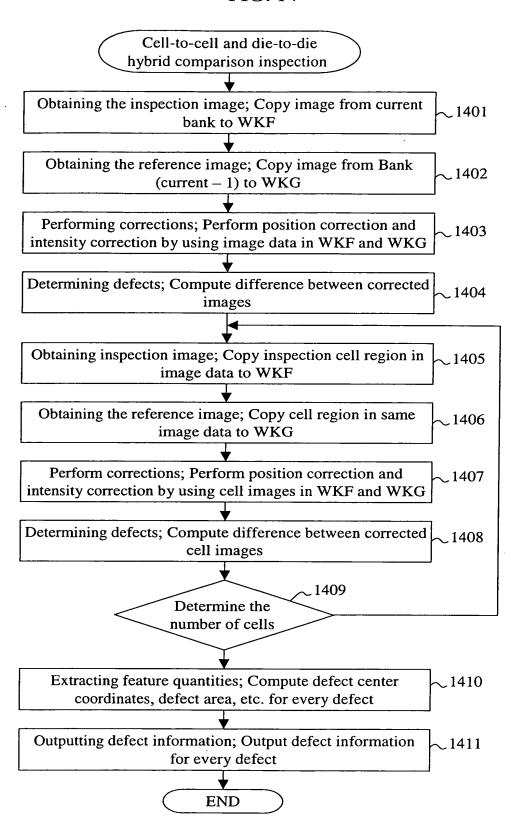
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FIG. 13



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FIG. 14



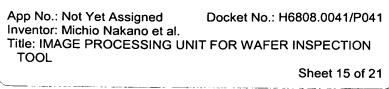
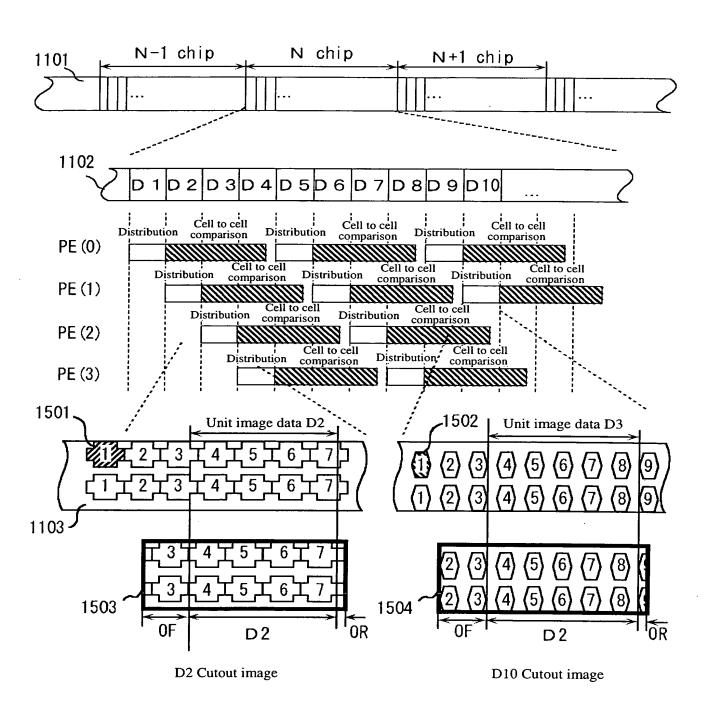
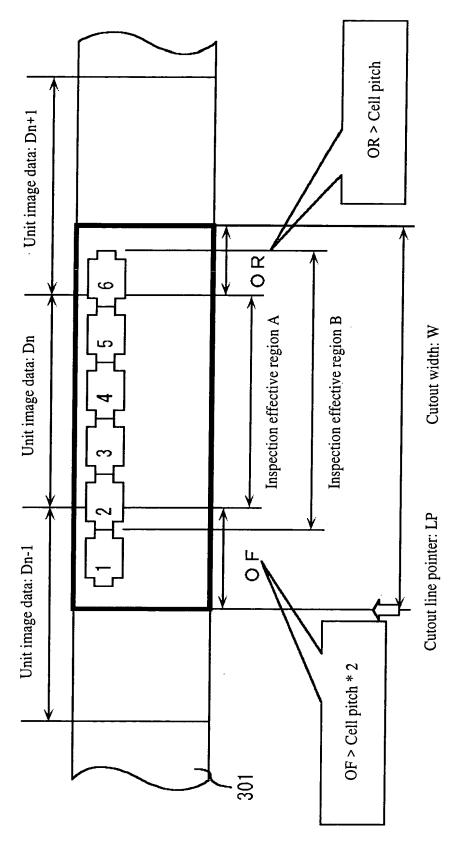


FIG. 15



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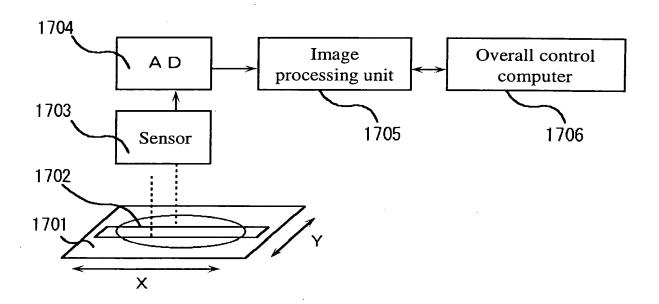
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FIG. 17



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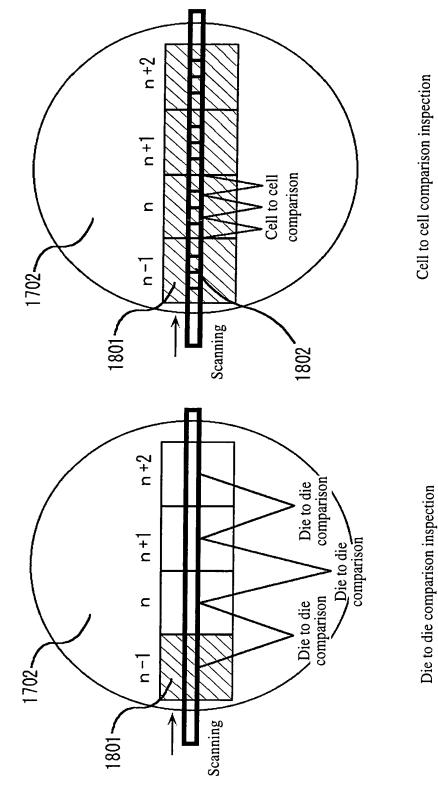
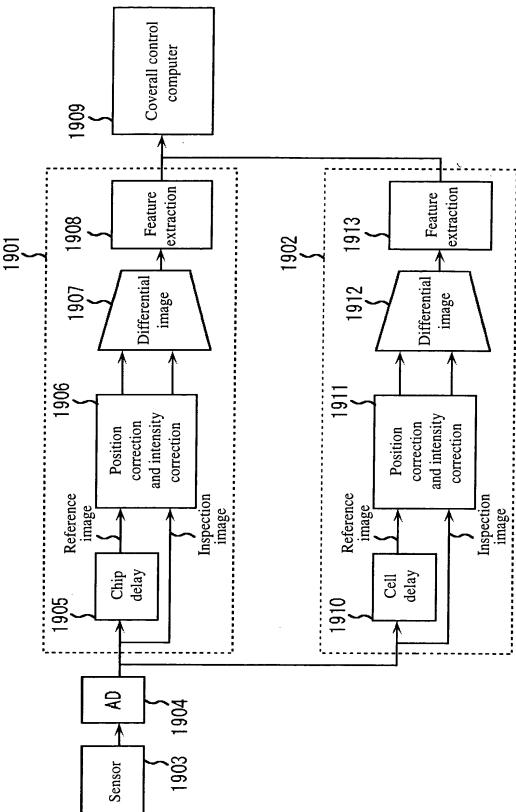


FIG. 18 A

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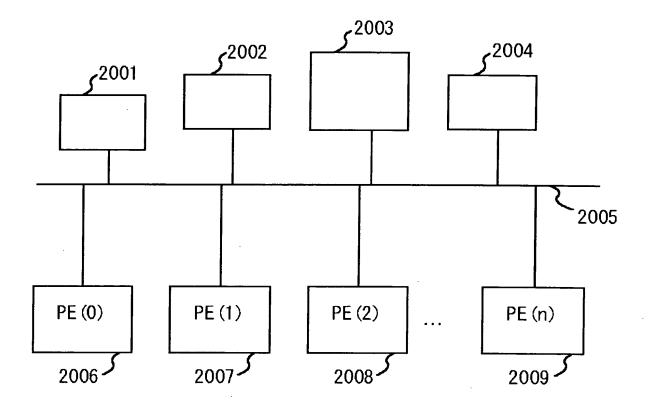
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FIG. 20



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FIG. 21

